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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

5/A
Patent

6/27/02

In re patent application of: TRAN et al.

Serial No.: NEW APPLICATION

Filed: On even date herewith

For: EPITAXIAL FILM

Examiner:

Art Unit:

Dckt No.: P07472US00/WEJ

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C.

S I R:

Prior to examination, please amend the above-identified application as follows.

IN THE CLAIMS:

A clean version of the amended claims is provided herewith in **Attachment A**. It will be noted that claims 1, 3, 4, 8 and 10-17 have been amended relative to the previously provided version as shown by the marked up version thereof in **Attachment B** provided herewith.

REMARKS

By this Amendment, the claims have been rewritten to reduce the multiple dependencies.

Further and favorable action is solicited.

Respectfully submitted,

Date: 12/19/01

By: Douglas E. Jackson
Douglas E. Jackson
Registration No. 28518

ATTACHMENT A

Clean Replacement/New Claims

Following herewith is a clean copy of the amended claims.

13. (Thrice Amended) A substrate as claimed in claim 12, wherein the substrate comprises silicon (111).

16. (Thrice Amended) A process as claimed in claim 15, wherein the substrate comprises silicon (111).

13. (Thrice Amended) A substrate as claimed in claim 12, wherein the substrate comprises silicon (111).